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PATENT

Customer No. 22,852

Attorney Docket No. 07553.0029

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
)  
Masaaki HAGIHARA et al. ) Group Art Unit: 1763  
)  
Application No.: 10/030,656 ) Examiner: A. Olsen  
)  
Filed: January 11, 2002 )  
)  
For: ETCHING METHOD AND )  
PLASMA PROCESSING METHOD )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PETITION FOR EXTENSION OF TIME**

Applicants hereby petition for a two-month extension of time to reply to the Office Action of August 26, 2003. A fee payment of \$420.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: January 26, 2004

By: David W. Hill  
David W. Hill  
Reg. No. 28,220

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